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Attorney Docket SEL 231



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )

Yamazaki et al. )

Serial No.: 09/724,002 )

Filed: November 28, 2000 )

For: Film Deposition Apparatus And )  
Method Of Manufacturing A Light )  
Emitting Device Using The )  
Apparatus )

Art Unit: 1763 )

Examiner: K. Moore )

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Cristina M. Noel

Date: December 18, 2003

Commissioner for Patents  
P. O. Box 1450  
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**RESPONSE (C) AFTER FINAL**

Sir:

Applicants have the following response to the Final Rejection dated July 18, 2003, a two  
month extension of time being submitted herewith.

Applicants will address each of the Examiner's rejections in the order in which they  
appear in the Final Rejection.